



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kori, et al.

Serial No.: 09/625,336

Confirmation No.: 7523

Filed: July 25, 2000

For: METHOD AND SYSTEM
FOR CONTROLLING THE
PRESENCE OF
FLUORINE IN
REFRACTORY METAL
LAYERS

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Group Art Unit: 1763

Examiner: Moore, Karla A.

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TC 1700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>June 27</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>6/27/2003</u> Date	<u>Minville Peret</u> Signature

Dear Sir:

RESPONSE TO OFFICE ACTION DATED MARCH 27, 2003

#221
7/31/03
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In response to the Office Action dated March 27, 2003, having a shortened statutory period for response set to expire on June 27, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4714.D1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.